

Ge - Germanium

Electrical properties

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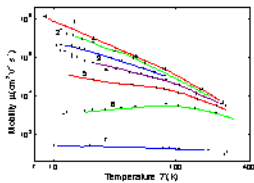
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Basic Parameters

Breakdown field	$\approx 10^5 \text{ V cm}^{-1}$
Mobility electrons	$\leq 3900 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$
Mobility holes	$\leq 1900 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$
Diffusion coefficient electrons	$\leq 100 \text{ cm}^2 \text{ s}^{-1}$
Diffusion coefficient holes	$\leq 50 \text{ cm}^2 \text{ s}^{-1}$
Electron thermal velocity	$3.1 \cdot 10^5 \text{ m s}^{-1}$
Hole thermal velocity	$1.9 \cdot 10^5 \text{ m s}^{-1}$

Mobility and Hall Effect

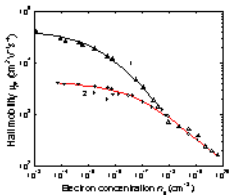


Electron mobility versus temperature for different doping levels.

1. High purity Ge; time-of-flight technique ([Jacoboni et al. \[1981\]](#));
- 2-6. Hall effect $N_d - N_a (\text{cm}^{-3})$:
 2. $1 \cdot 10^{13}$; 3. $1.4 \cdot 10^{14}$; 4. $1.7 \cdot 10^{15}$; 5. $7.5 \cdot 10^{15}$; 6. $5.5 \cdot 10^{16}$ ([Debye and Conwell \[1954\]](#));
7. Hall effect $N_d - N_a = 1.2 \cdot 10^{19} (\text{cm}^{-3})$ ([Fistul et al. \[1962\]](#)).

For weakly doped Ge in the range 77-300 K electron mobility

$$\mu_n \approx 4.9 \cdot 10^7 \cdot T^{-1.66} (\text{cm}^2 \text{ V}^{-1} \text{ s}^{-1}).$$



Electron Hall mobility versus electron concentration

1. $T = 77 \text{ K}$;
 2. $T = 300 \text{ K}$.
- ([Fistul et al. \[1962\]](#)).

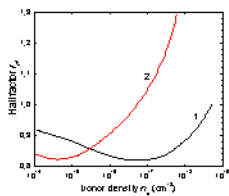
Approximate formula for the Hall mobility. 300 K.

$$\mu_n = \mu_{OH} / (1 + N_d \cdot 10^{-17})^{1/2},$$

where $\mu_{OH} \approx 3900 (\text{cm}^2 \text{ V}^{-1} \text{ s}^{-1})$,

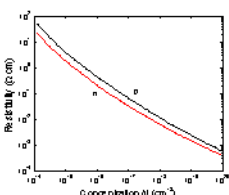
N_d - in cm^{-3}

([Hilsun \[1974\]](#)).



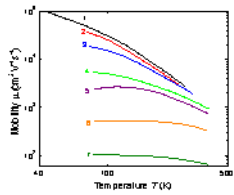
The electron Hall factor versus donor density.

1. $T = 300 \text{ K}$;
2. $T = 77 \text{ K}$. ([Babich et al. \[1969\]](#)).



Resistivity versus impurity concentration., $T = 300 \text{ K}$.

([Cuttris \[1981\]](#)).

**Temperature dependences of hole mobility for different doping levels.**

1. High purity Ge; time-of-flight technique ([Ottaviani et al. \[1973\]](#)).

2-7. Hall-effect ([Golikova et al. \[1961\]](#)).

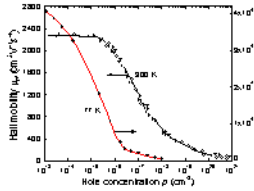
$N_a - N_d$ (cm⁻³): 2. = $4.9 \cdot 10^{13}$; 3. $3.2 \cdot 10^{15}$; 4. $2.7 \cdot 10^{16}$; 5. $1.2 \cdot 10^{17}$; 6. $4.9 \cdot 10^{18}$; 7. $2.0 \cdot 10^{20}$.

For weakly doped Ge in the range 100-300 K hole mobility

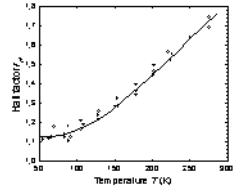
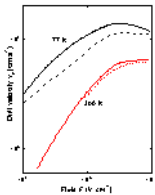
$$\mu_p \approx 1.05 \cdot 10^9 \cdot T^{-2.33} \text{ (cm}^2 \text{ V}^{-1} \text{ s}^{-1}\text{)}$$

The hole Hall mobility versus hole concentration.

Experimental points: data from three References ([Golikova et al. \[1961\]](#)).

**The hole Hall factor versus temperature for high purity p-Ge**

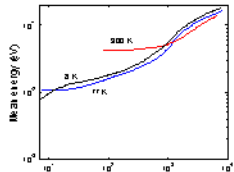
([Morin \[1954\]](#)).

**Transport Properties in High Electric Fields****Field dependences of the electron drift velocity.**

Solid lines: F||(100)

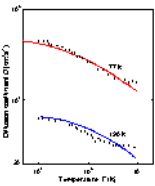
Solid lines: F||(111).

([Jacoboni et al. \[1981\]](#)).

**Mean energy of electrons in lower valleys as a function of electronic field for three lattice temperatures.**

([Jacoboni et al. \[1981\]](#)).

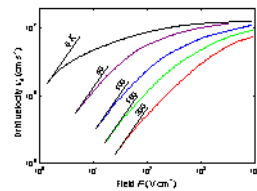
([Jacoboni et al. \[1981\]](#)).

**The field dependence of longitudinal electron diffusion coefficient D for 77 K and 190 K. F||(100).**

Solid lines show the results calculation.

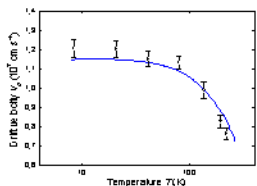
Symbols represent measured data.

([Jacoboni et al. \[1981\]](#)).

**Field dependences of the electron drift velocity at different temperatures.**

F||(100).

([Ottaviani et al. \[1973\]](#)).

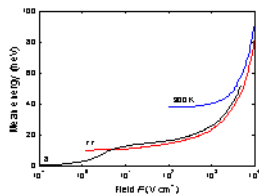
**Drift velocity v_d as a function of temperature**

for electric field $F=10^4$ (V cm⁻¹), F||(100).

Solid line show the results of calculation in the case where non-parabolic effect are taken into account ([Reggiani et al. \[1977\]](#)).

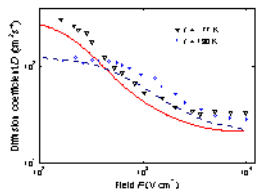
Mean energy of hole as a function of electronic field F at different lattice temperatures.

Solid line are Monte-Carlo calculations for F||111) ([Reggiani et al. \[1977\]](#)). Points show experimental results for 82 K. ([Vorob'ev et al. \[1978\]](#)).



The field dependence of longitudinal hole diffusion coefficient D

for 77 K and 190 K, F||111). Dashed and solid lines show the results of the calculations. Symbols represent measured data. ([Reggiani et al. \[1978\]](#)).



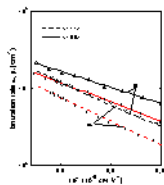
Impact Ionization

There are two schools of thought regarding the impact ionization in Ge.

The first one states that impact ionization rates α_i and β_i for electrons and holes in Ge are known accurately enough to distinguish such subtle details as the anisotropy of α_i and β_i for different crystallographic directions.

Ionization rates in (111) and (100) directions versus 1/F. T = 300 K.

([Mikava et al. \[1977\]](#)).



From ([Mikava et al. \[1980\]](#))

For electrons: $\alpha_i = \alpha_o \exp(-F_{no}/F)$

(111) direction $\alpha_o = 2.72 \cdot 10^6 \text{ cm}^{-1}$ $F_{no} = 1.1 \cdot 10^6 \text{ V cm}^{-1}$

(100) direction $\alpha_o = 8.04 \cdot 10^6 \text{ cm}^{-1}$ $F_{no} = 1.4 \cdot 10^6 \text{ V cm}^{-1}$

For holes: $\beta_i = \beta_o \exp(-F_{po}/F)$

(111) direction $\beta_o = 1.72 \cdot 10^6 \text{ cm}^{-1}$ $F_{po} = 9.37 \cdot 10^5 \text{ V cm}^{-1}$

(100) direction $\beta_o = 6.39 \cdot 10^6 \text{ cm}^{-1}$ $F_{po} = 1.27 \cdot 10^6 \text{ V cm}^{-1}$

The second school contends that the values of α_i and β_i for the same electric field reported by different researches differ by an order of magnitude. This point of view is explained by [Kyuregyan and Yurkov \[1989\]](#). In accordance with this approach we can assume for all crystallographic directions that

For electrons: $\alpha_i = \alpha_o \exp(-F_{no}/F)$

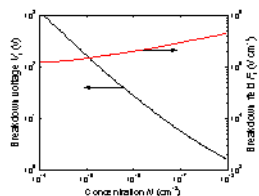
where $\alpha_o = 2.84 \cdot 10^6 \text{ cm}^{-1}$ $F_{no} = 1.14 \cdot 10^6 \text{ V cm}^{-1}$

For holes: $\beta_i = \beta_o \exp(-F_{po}/F)$

where $\beta_o = 4.21 \cdot 10^6 \text{ cm}^{-1}$ $F_{po} = 1.11 \cdot 10^6 \text{ V cm}^{-1}$

Breakdown voltage and breakdown field versus doping density for an abrupt p-n junction.

([Kyuregyan and Yurkov \[1989\]](#)).



Recombination Parameters

Pure n-type material

300 K

The longest lifetime of holes

$$\tau_p \geq 10^{-3} \text{ s}$$

Diffusion length

$$L_p \geq 0.2 \text{ cm}$$

77 K

The longest lifetime of holes	$\tau_p \geq 10^{-4}$ s
Diffusion length	$L_p \geq 0.15$ cm

Pure p-type material**300 K**

The longest lifetime of electrons	$\tau_n \geq 10^{-3}$ s
Diffusion length	$L_n \geq 0.3$ cm

77 K

The longest lifetime of electrons	$\tau_n \geq 10^{-4}$ s
Diffusion length	$L_n \geq 0.15$ cm
Surface recombination	$10 \div 10^6$ cm/s.

Radiative recombination coefficient at 300 K $6.41 \cdot 10^{-14}$ cm³ s⁻¹**Auger coefficient** at 300 K $\sim 10^{-30}$ cm⁶ s⁻¹